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APPLICANTS

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NONE, CA

** CONTINUING DATA *****

YES, CA

** FOREIGN APPLICATIONS *****

JAPAN 11-329324 11/19/1999

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 02/26/2001

Foreign Priority claimed	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR	SHEETS	TOTAL	INDEPENDENT
35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	COUNTRY	DRAWING	CLAIMS	CLAIMS
Verified and Acknowledged Examiner's Signature	Initials	JAPAN	11	56	4

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TITLE

Improved semiconductor wafer surface and method of treating a semiconductor wafer surface

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____
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